List of items likely to be procured in the next 3-5 years

Note:

- 1. This list may change from time to time depending on project requirements.
- 2. Detailed specifications will be available at the time of raising the indent.
- 1. MS and SS chambers with refractory and thermal insulation linings from inside like in a furnace.
- 2. IGBT based power supply of rating 100kW
- 3. Process Instrumentation and sensors with PLC based feedback controls integrated in control panel.
- 4. Steam based medical waste sterilization equipment made of SS material with accessories
- 5. Heavy duty industrial shredder to shred sterilized red category biomedical waste
- 6. Effluent treatment plant to treat water from discharge of wet scrubbers and other equipment consisting of sedimentation, dosing tanks and filter press.
- 7. Diesel generator for emergency backup
- 8. Oxygen and Nitrogen generators based on swing adsorption technique
- 9. RF power supply (1KW, single phase along with matching network)
- 10. Pressure gauges
- 11. Heaters and heater power supply
- 12. Mass Flow Controller
- 13. Water chiller
- 14. High-Temperature Vacuum Furnace with High-Pressure Gas Quenching
- 15. Multi-stage roots pumping station
- 16. Vacuum Chambers of various dimensions
- 17. Optical Emission Spectrometer
- 18. Ion Source for Producing ion beam of energy range 50 2000 eV
- 19. UHV system of various dimensions
- 20. SNOM AFM Scanner,
- 21. FTDT/SPIP software
- 22. Portable Raman system
- 23. Compact e-beam evaporator
- 24. Turbo Molecular pump of various specifications
- 25. High Vacuum SS Chamber (Spherical, Diameter: 500 mm with load lock)
- 26. HIPIMS Power supply (6 KW, 3 phase)
- 27. Ion energy analyzer
- 28. Vacuum Chamber and subsystems
- 29. Power supplies
- 30. Quantum Efficiency Measurement
- 31. H₂S detectors and Upgradation of safety system
- 32. Diesel generator
- 33. Flue Gas Analyzer,
- 34. Power supplies,
- 35. Experimental system + PS for electric and magnetic fields,
- 36. Turbo pump
- 37. AFM scanner
- 38. Vibrating sample magnetometer (VSM),
- 39. Experimental plasma pyrolysis chamber

- 40. RF Components such as amplifier, Directional antenna system, and Broad band Antennas and SDR etc.
- 41. Controlling systems for vacuum and power supplies such as comsole, leak detector, high voltage power supply etc.
- 42. Radiation measuring systems such as Wein Filter, Spares gamma and neutron detectors, HV feed through, Insulator etc.
- 43. System for RF applications on seeds or similar etching system such as Water Contact Angle Measurement Instrument, Optical Emission Spectroscopy up gradation, Florescent Microscope etc.
- 44. High Voltage Probe & Current Transformers (CTs)
- 45. High speed RF switch 2GHz to 20 GHz (SPDT)
- 46. ZERO-BIAS SCHOTTKY DIODE DETECTORS 2GHz to 20GHz
- 47. RF Power Meter with Diode sensors 2GHz to 20GHz
- 48. Semiconductor devices (100 Ampere, 1.5kV) IGBT, Diodes, MOSFets, Diodes, SCRs
- 49. Hot Wire Anemometer, 0-30m/s
- 50. Vector Network Analyser (1MHz to 20 GHz)
- 51. Combination Vacuum gauge (1500 mbar-10(-8)mbar)
- 52. Turbo Molecular Pump (80 liter/sec)
- 53. Bidirectional couplers 2GHz to 20 GHz
- 54. Voltage controlled oscillator 2GHz to 20GHz
- 55. Gas dosing valve (high Precision)
- 56. Circulators 1 GHz to 2 GHz
- 57. Spectrum Analyser (10kHz to 20 GHz)
- 58. CW 13.56 MHz RF source with impedance matching network for making of plasma, impedance range=0.1 to 10 ohm
- 59. Stub tuner for matching impedance in frequency range of 100-500 MHz with power handling capacity 100 watt
- 60. RF Power meter for (-20dBm to +50 dBm) with frequency range 10-500 MHz
- 61. Power Amplifiers for 10-500 MHz for 100 watt output
- 62. Programmable software defined radio SDR (transceiver) for frequency 50 MHz to 3 GHz
- 63. Tunable RF filters with High power handling of 100 watt in frequency range 10-500 MHz
- 64. RF Fixed attenuators, high-power attenuators, digital step / programmable attenuators, voltage variable attenuators from DC to 1 GHz with 20dB attenuation
- 65. Signal generator (2 GHZ/18 GHZ)
- 66. Radiation measurement meter (frequency upto 20 GHZ)
- 67. optical emission spectrometer in 320-1000 nm wavelength range and focal length >300mm, optical resolution of 0.2nm
- $68. \ CW \ Signal \ generator \ (\ 9kHz-3GHz) \ with \ FM, AM \ modulation \ and \ output \ power \ of \ -120 \ to \ 10dBm$
- 69. NF3 gas detector 0-30ppm
- 70. Mass flow controller (NF3 gas) 0-500 sccm
- 71. 40 KF FUSED SILICA (QUARTZ) VIEWPORT
- 72. UHV gate valve with DN 100 CF flange
- 73. "Wien Filter with a fixed magnetic field (with rare-earth permanent magnet circuit) and a set of electrostatic plates.
- 74. Fission Chamber/Boron lined proportional counter: 1500 mm to 400 mm
- 75. Neutron and Gamma Area monitor: He3 and GM counter
- 76. Bending Magnet

- 77. Linear Induction Motors 0 to 415V, ~1kA (short pulse)
- 78. 3-phase, 415V, Variable Frequency Drives
- 79. Alpha detector
- 80. Workshop machines (CNC VMC, shearing machine with accessories)
- 81. 12 MW Water Cooling System
- 82. Wi-Fi Access Points & Controller
- 83. Containerized Data Center turnkey project with 8 racks
- 84. High Configuration Server
- 85. Routers with 10G interface
- 86. "Multiparty VC End Points,
- 87. Multi Control Unit (MCU)"
- 88. 2 Petabyte Storage System solution
- 89. VDI (Virtual Desktop Infrastructure)
- 90. Smart Class Room with accessories
- 91. "Desktop Computers
- 92. (All-In-One, Desktop Computers)"
- 93. Multi-Function Printers
- 94. Network Access Control solution for the campus network
- 95. High Configuration Server Hardware
- 96. Data Backup Solution for minimum 500TB storage
- 97. GPU-CPU cluster (NVlink or equivalent configuration)
- 98. Position control power supply (Feedback power supply rating 300 V, +/- 3 kA.)
- 99. Divertor Power Supply (300V, 30 kA)
- 100. Cryo valves for helium as well as nitrogen services (On-off, control or Hand valve, Electro/pneumatic valve)
- 101. Impurity detector (Trace Impurity of N2, O2, Moisture and THC in Helium gas, Range: 0-100 ppm
- 102. PLC Upgradation of Cold-Box (Upgradation PLC module of cold-box Eurotherm T2750 PAC modules, IO: 140 nos., # 02 CPU with designated 16 modules racks, 08 module AI, 09 AO, 01 DI and 12 nos. of DO
- 103. Cryo Temperature Sensors (Range: 4.2 K 325 K), Model: Cernox or CCS
- 104. Cryo compatible Resin Epoxy (10 Kg)
- 105. Stainless Steel Pipes (SS 316 L, Size: ½ in to 4 in (NB), Length: 10 m)
- 106. S-Glass Roving (9 micron, 360 tex, S-Glass Yarn)
- 107. Oil consumables for Rotary and Roots vacuum pumps 50 L container x 02 nos., P3 grade Oil)
- 108. Breox Oil (B35) and Charcoal (Breox B35 Oil for He compressors 200 L x 3 drums, 200 kg Charcoal)
- 109. ORS, POS and Purifier Filters for periodic maintenance
- 110. Filter FC 410 & FC 418 for Helium cold box
- 111. O-rings / Gaskets / seals (10 kF, 16 kF, 25 kF, 40 kF and 50 kF
- 112. Material: Viton / Nylon / Teflon PFTE)
- 113. Cryo Compatible Bellows (SS 316 L, Size: ½ in to 4 in (NB), Length: 0.25 -1 m)
- 114. Multi-layer Insulation (MLI) (Aluminized Mylar, Fibre Glass Net as spacer material, Punched holes, 100 m L and 1 m width Roll)
- 115. HTS Tape BISCCO or YBCO (Bi-2223 or Di-BSSCO, YBCO, L: 50 m, Critical Current at self-field at 77 K: > 120 A)

- 116. MgB2 wires (L: 500 m, Critical Current at self-field at 77 K: > 50 A)
- 117. Helium gas (Qty: 2000 M3, Purity: 99.999% (4.6 Grade Helium gas))
- 118. Liquid Nitrogen (Qty: 24 Lacs Liters (Every Year 8 Lacs x 3 Y), Purity: 99.999%)
- 119. PLC cards AO/AI for Compressors station
- 120. Consumables for Pneumatics Utility
- 121. Sub-components for Current leads
- 122. Helium Leak Detector (3 nos.) (1. Backing pumps capacity from 15 to 35m3/h. 2. Pumping Speed capacity from 2 to 10 l/s. 3. Vacuum and sniffing leak detection)
- 123. UHV Gauge Heads (15 nos.) (Replacement gauge heads with CF fitting compatible with M/s. Granville Phillips (MKS) make 356 Micro-Ion Plus modules -P/N: 356006-YG and 274 UHV Nude Gauge Flange P/N: 274042.)
- 124. RGA Ion Source (10 nos.) (Replaceable Open Ion Source with Dual Thoria Filaments for MKS022 Series RGA (MKS make) P/N: 842-043)
- 125. Ionization Gauge (4 nos.)
- 126. Turbo molecular pump Hi pace 300 bearings (15 nos.)
- 127. Turbo molecular pump Hi pace 2300 bearings (15 nos.)
- 128. Oil consumables for Rotary and Turbo molecular vacuum pumps
- 129. Annual maintenance contracts
- 130. AMC of Pfeiffer make Pumps and helium leak detectors
- 131. Divertor Power Supply for Aditya-U
- 132. PF-6 Power Supply for SST-1
- 133. Up-gradation of Plasma Control System H/W and S/WController, A/D, D/A, Timer and DIO modules along with software drivers
- 134. Supply and Installation of Turbo Molecular Pumping System with 150 CF Inlet Flange and Nitrogen Pumping Speed ≥ 650 l/s
- 135. Supply and Installation of Turbo Molecular Pumping Systemwith 250 CF Inlet Flange and Nitrogen pumping Speed ≥ 1900 l/s
- 136. Mass Flow Controller (MFC) with Local Display Unit and mass Flow rate 50, 100, 300 SCCM
- 137. Residual Gas Analyzer with 200 AMU Including Electronics Unit
- 138. Supply and Installation of Cryo Pumping System with 300 CF Inlet Flange and Water pumping Speed ≥ 9000 1/s
- 139. DCCT for pulsed and continuous operation; a) \pm 2 kA; a) \pm 5 kA; a) \pm 4-14 kA; a) \pm 4-20 kA
- 140. Power supplies and DAQ for magnet system
- 141. Upgradation of 82.6 GHz, 200 kW Gyrotron
- 142. 35kV Power supply
- 143. UV-VIS Spectrometer (200 700 nanometre)
- 144. CCD cameras
- 145. X-ray (0.5 KeV-100 KeV) Imaging systems
- 146. Fast Optical imaging system in visible spectrum
- 147. Phase Quadrature (IQ) Analyser (1-42 GHz) + Lab Equipments
- 148. Heterodyne Interferometer Systems (140 GHz) 7 nos.
- 149. Microwave assemblies for 16-channels Radiometer (60 -110 GHz)
- 150. Millimetre Wave vibration time-series systems (90 GHz) & VCO assemblies (26 40 GHz)
- 151. Closed Loop Detector System for Michelson Interferometer (75 1000 GHz)
- 152. Vacuum pumps and components for Time of Flight System of Neutral Particle Analyzer (NPA).

- 153. Infrared cameras
- 154. Compact Charge Exchange- Neutral Particle Analyzer (for 100 eV 1 KeV ion temperature) System
- 155. Vacuum, RF components, Electrical component, Power Supply
- 156. Fabrication and testing of TF coils (12.5 kA, 250 ms flat top Multi-stage Capacitor bank based Power Supply with a ramp rate of 1.5 MA/s)
- 157. New VF Power Supply
- 158. Equipment related with LN2 sub cooled system
- 159. Fabrication of one shaped coil
- 160. Fabrication of a solenoid coil producing magnetic field up to 3T
- 161. Procurement of vacuum components
- 162. Procurement of cryogenic components
- 163. Procurement of diagnostic equipment
- 164. Procurement of control equipment
- 165. Equipment for Characterization facility of different structural & functional materials
- 166. Equipment for integration of EHCL and HHF Test Facility
- 167. Cryocoolers
- 168. Calorimeter
- 169. Enhance data acquisition system of existing tokamaks -Aditya-U diagnostic data acquisition system: SST-1 central data storage capacity expansion; Server hardware for various DAC services
- 170. DAC system for ST
- 171. Motors + Gearbox + controllers + IPC for Hyper-redundant Inspection System
- 172. Power supplies, oscilloscope, function generator, Isolation transformers, soldering de soldering stations
- 173. 70 kV, 42 A HVDC power supply for ECRH and LHCD System
- 174. 35 kV, 105 A HVDC power supply for ICRH System
- 175. Tunable Diode Laser
- 176. RF Generators
- 177. Visible Spectrometer
- 178. TMP, Gate Valves & Gauges
- 179. DAC modules
- 180. Experimental chambers
- 181. High current power supplies for different magnet systems
- 182. Magnets
- 183. High Power microwave Coupler
- 184. Microwave components
- 185. Optical and Opto-Mechanical components
- 186. Energy Storage Capacitor
- 187. Thermogravimetric Analyzer, Vickers hardness tester, FTIR Spectrometer
- 188. W-Cu made segmented plasma torches
- 189. Electrical & Electronics components
- 190. Instrumentation feedthrough and view ports
- 191. Optical and Opto-Mechanical components
- 192. Graphite electrodes Sod. Hydroxide, etc.

- 193. Consumables for nano powder production; Consumables for sterilization; Consumables (Ag, Au, wafers, sharp tip, gas, Desiccators, Freezer, maintenance of all systems, AFM tips, TEM grids, thermocouples etc.)
- 194. Consumables like targets, AFM tips, TEM grids, heaters, thermocouples, H2S Gas, SS foil, Ar, N2, O2 UHP gases and commercial gases
- 195. Different gases and materials required for etching and neutronics such as deuterium, silicon wafers and Tritium Target
- 196. Installation and commissioning of hardware for digitization and integration for electrical distribution system of 132 kV Substation
- 197. Rooftop Solar Power System, LED lightings & spares and maintenance of Utility Power systems
- 198. Ferrous and non-ferrous metallic and nonmetallic materials for Workshop
- 199. Pipes, fittings, valves, tanks, pressurizers, cables, PLCs etc. for Water Cooling Plant
- 200. VFPS Upgradation
- 201. OTPS and Wave shaping circuit upgradation and new VFPS
- 202. Procurement of power supply spares and transformer overhauling
- 203. Liquid nitrogen and helium gas consumables
- 204. Cryogenic accessories and spares
- 205. Manufacturing of current leads
- 206. Cryo-plant maintenance and spares
- 207. Manufacturing of 4 Nos. of current leads
- 208. Upgradation of hot N2 system
- 209. Delivery of hardware components
- 210. Delivery and testing of controller
- 211. Testing and commissioning of rectifier circuit
- 212. Components for Solid state crowbar Thyristors etc.
- 213. Components for Solid state Switch (IGBTs), Power supplies, CTs, probes etc.
- 214. Liquid Helium
- 215. HVDCPS, Consumables, Ferrite, Ceramic, Magnet, Copper disc, SS disc, etc.
- 216. Accessories and parts of Hard x -ray and soft ray systems
- 217. Thomson Scattering System Installation at Aditya-U
- 218. Prototyping and fabrication work of components
- 219. Procurement HTS tapes/2G HTS wire and associated consumable
- 220. Procurement of structural materials for shaped coils
- 221. Procurement of cryogenic accessories and consumables
- 222. Procurement of flexible cryostat
- 223. Professional services required for experiments performed in EHCL and HHF facility
- 224. Fabrication, Assembly and Testing of Target Handling System for HHFTF
- 225. RCC-MR double walled bellow of diameter ~2m
- 226. elliptic metallic seals 2 m x 0.7 m for UHV boundary
- 227. CFC Tiles
- 228. Prorotype THE with improved design
- 229. Fabrication of faraday cage
- 230. Vacuum vessel and vacuum pumps for xenon pumping, gate valves, gauges, mass flow controllers, water cooler, vacuum feed-through
- 231. CNC machining of extractor Grid and fixtures

- 232. Electrodeposition of OFHC copper
- 233. UPS power for tokamak systems.
- 234. Gases (Deuterim, helium, argon etc.)
- 235. Motors + Gearbox + Encoders + controllers + IPC for Single Arm Manipulator and Dual Arm Manipulator System
- 236. Gripper for Single Arm Manipulator and Dual Arm Manipulator System
- 237. Vision (Hand and Head Camera) and lighting system for Single Arm Manipulator and Dual Arm Manipulator System
- 238. Motors + Gearbox + Encoders + controllers for Winch System
- 239. Force Torque sensors, temperature sensors, electrical feed-throughs for Single Arm Manipulator and Dual Arm Manipulator System
- 240. Prototype Single Arm Manipulator and Dual Arm Manipulator System
- 241. Design, Fabrication, Assembly, Installation and Commissioning of Single Arm Manipulator, Winch System and Dual Arm Manipulator System